



IFW

Docket: P910235

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application:

Jiun-Ren Lai

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Application No. 10/627,115

/ Group Art Unit: 2822

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Filed: July 25, 2003

/ Examiner: Graybill, David E.

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For: METHODS FOR REDUCING CELL
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